

D2AM/CRG-ESRF LGC-CNRS SOLEIL
Grenoble S. . . .



D2AM-CRG/ESRF detector requirement

 $\begin{array}{lll} \mbox{dynamic range} & > 10^9 count/pixel & > 32 \mbox{ bits architecture} \\ \mbox{saturation rate} & > 10^7 v/s/pixel & > \mbox{noise} < 0.1 v/s/pixel \\ \mbox{energy range} & 5 - 25 keV & \mbox{from beamline} \\ \mbox{pixel size} & 250 \times 400 \mbox{ } \mu \mbox{mean spot size in 1995} \\ \mbox{exposure time} & 1ms - 1000 s & \mbox{kinetics potentiality} \end{array}$ 

The silicium thickness  $300\mu m$  and the pixel size:  $330 \times 330\mu m^2$  were convenient to our beamling requirements leading to the project of buildind a new X-ray detector taking benefit of the Delph detector peoples knowledge.

ERW.

Measured counts as a function of the threshold for the diffusion of a Br solution on both sides of Br absoption edge.

Fiber Optic CCD

CPPM-IN2P3-CNRS Marseille



High energy physics experiments lead to built detector like Delphi at CERN which uses the potentiabilities offered by microelectronics and direct photon conversion in silicon.

Dead area in pixel detectors

Within modules: No dead area Pixels at the border of the chip are connected to pixel diode with an increased surface to avoid dead area associated with the packing of chips on the detector: me-

chanical border, guards ring..

Between modules : ≈

pixel/column ⇒ 4% XPAD2

Energy resolution

The conversion of incoming photons in silicon leads to a charge proportional to the incoming energy. The XPAD chip energy resolution is near  $1\,keV$ .

20 16 12

Pixel threshold register : 4 bits (XPAD1) → 6 bits (XPAD2)

SAXS application (2)

The low noise achieved with the same XPAD detector allows to improve the measurement of weak scatterer like water: the signal observed without sample is really lower with XPAD at than with the CCD (morecenes, FSF tais...)

Data have been compared with FOB CCD\* ones using the same setting.

\* PI-SCX-1300, Roper Scientific (EEG 1340x1300, 50µm pixel size, dark corrected)

Whole electronic designed to allow kinetics studies (ms range)

Kinetics potentiality of XPAD2

18 14 10 22 24

pixel/column ⇒ → 1% XPAD3

Feb. 17th, 2006 Campinas sincrotron

### On D2AM-CRG/ESRF beamline (BM2).

and photomultipliers to reach the required quality.

eras with indirect photon detection are commonly used.



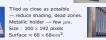
Diffuse scattering in icosaedral quasi-crystals: 7 orders of magnitude are necessary to measure this signal. Dynamic extended by attenuators, time consuming mapping effects

Data from M. de Boissieu, see Phil. Mag. Let. (2001) 81, 273-283 and (2003) 83, 1-29

## XPAD2 detector : 8 modules $\times$ 8chips



Diode = 8 chips of 24  $\times$  25 pixels PCB card : drivers and regulators. Modules = acquisition card Alterra Nios kit + ethernet

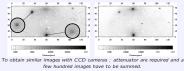






#### Dynamical range (XPAD1 application)

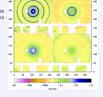
Diffusion (left) of a CdYb icosahedral quasicrystal and associated r age (right) on which the highest peak is near counter saturation rate, it cross the Ewald sphere within a few part of the exposure!



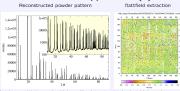
# SAXS application (1)

- Ag Behenate
   Bee waxs

- Polyurethan Empty cell Teflon
   Water (5mm)



# Powder diffraction application (3)



# Multilayers: Ferroelectric superlattice







Out of same: stanit / demical h plane: 3 PTO domains tetragonal distortion. The reciprocal maps are recorded scanning the KPAD detectors and rebuilt from the collected reciprocal slices. Compared to standard data collection that time can be reduced by 100. Intensity on substrate peak can reach  $10^9\nu/s$  ! F. Lemannic, E. Dooynea and cos. LUC: (2000) Planeros, Elby.

# Summary.

- Detectors & material sciences scattering

  XPAD project and prototypes

  Resolution, dynamical range, . . .

  XPAD2 calibration and dispersion

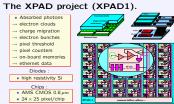
  SAXS application

  Powder diffraction application

  Kinetics potentiality

  Multilayer studies

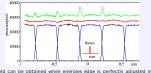
  from XPAD2 to XPAD3



Boudet et all., NIM AS10 (2003) 41-44,

#### Spatial resolution

the diode is common to pixels belonging to the same chip, me charge sharing may occurs between adjacent pixels. assurements show that the charge sharing occurs on  $\approx 60\,\mu m$ .



-I -0.5 0 0.5 mm

A flat field can be obtained when energies edge is perfectly adjusted in each pixel (red). In case of too low edges, this share sharing create some overcounting at pixel borders (green).

# XPAD2 calibration and dispersion (1)



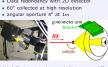
- beam  $E_s$ : monochromatic flat scattering (amorphous), noisy, time expensive injection  $E_{inj}$ : simulate the beam, quick and easy but need calibration Each pixel is described by C;  $\alpha_s \beta_s E_{inj}(nsise)$   $E_s = (E_{inj} = \alpha(I_{ih}) + \beta(I_{obs})$   $E_s(nsise) = CE_{inj}(nsise)$   $\approx 410^4$  bybels  $\Rightarrow$  automatic configuration/calibration procedure.

Knowing then these characteristics : the setup of each chip at a given energy E can be defined as the value of the chip common threshold level  $I_{th}$  for which most of the pixels can be fine tune,  $I_{dac} \in [0,63]$ .



### Powder diffraction application (1)

Data redondancy with 2D detector



With 0-D detector pipes and slits remove diffuse scattering, background level partly removed with conic pipes on 2d-detector.

Raw images with Brage lines, low and high angles



### Kinetics of quench studied by diffraction

Data collection is limited by the cell aperture, which has been designed for linear detector, a few frames of 20ms around crystallisation shown at 10 frames/s.



OBSTANCE CAN The quench of  $Al_{2\mu}Ca_{9}O_{3x+y}$  ceramics can lead to vitrous or crystalline oxides. The transition between the liquid state and the cristalline one occurs in less than 20ms and may exhibit some transient phases.

Intensity range in scattering experiments 

Detectors & material sciences scattering

$$\label{eq:local_local_local} \begin{split} & \textbf{Imaging} : \rightarrow \textbf{X}\text{-ray microscopy, X-ray topography, X-ray radiography} \\ & \textbf{Spectroscopy} : \text{chemical composition (XAS), short order range (EXAFS)} \\ & \textbf{Scattering} \quad \text{by beam} \rightarrow I(Q) \propto F^2(\rho)c) \end{split}$$

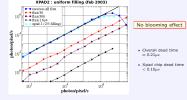
- Synchrotron  $\rightarrow$  current flux on sample :  $10^{11} 10^{14} \nu/s$
- $\bullet$  Spot size at sample or detector position :  $1\times5\rightarrow0.05\times0.10\,\text{mm}^2$
- $\bullet$  Counting rate :  $10^9\nu/s$  within  $10^{-2}mm^2$ • Resolution : angular  $10^{-3}$   $^o$   $\rightarrow$   $100 \, \mu m$  at  $0.5 \, m \approx 0.01$   $^o$

### XPAD detectors.



#### Dynamical range

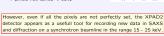
djacent pixels as a function of the incoming flux XPAD2 : uniform filling (feb 2003)



#### XPAD2 calibration and dispersion (2)

- XPAD2 initial threshold dispersion 60 e<sup>-</sup>
   ⇒ pixels not tuned < 3%
   manufacturing problems:
  leakage in bumping process
   ⇒ new foundry using the same masks
   threshold dispersion increase strongly

- ⇒ pixels not tuned < 15%



### Powder diffraction application (2)

 $Film : q \in Image_i \rightarrow p \in Image_{merool} : q = q(p, p)$ Minimisation:  $\sum_{p} (Y_p - N_p^{-1} \sum_{i} f_q y_{q,i})^2$ Powder lines :  $Y_{p \in Ring} \rightarrow Y_{Ring}$   $\sum_{Ring} (Y_{Ring} - N^{-1}_{Ring} \sum_{p \in Ring} \sum_{i} f_{q} y_{q,i})$ 



### Multilayers

Epitaxialy grown multilayer are now common samples to characterize: they need mapping of the reciprocal space which is time consuming. At the time such maps are recorded with silts and fixed (h,k,l) point of the reciprocal lattice, attenuators are often required near the substrate.



2-D detection allows an important improvement in these acquisitions but it needs to be able to manage high dynamics and to transform your reciprocal silices or volumes into reciprocal maps.



# from XPAD2 to XPAD3

Whole electronic designed to allo 
on-board memories 32 bits 
exposure time: 1 ms - 8300s 
dead time for reading: 
- whole image 2 ms 
overflow 16 gs each 10 ms 
on-board storage: 
- 423 images < 10 ms 
- 423 images > 10 ms

of a 2s movies showing diffraction while the sample crosses the beam at D2AM SAXS camera.

- A new YBAD3 using 0.25 ..... technology with 25 ..... humps

| A new At ADS using 0.25 pm technology with 25 pm bumps |                                 |                              |                    |
|--|---------------------------------|------------------------------|--------------------|
|  | XPAD2                           | XPAD3                        | comments           |
| polarization   | both                            | e <sup>+</sup>               | 2 chips : Si, CdTe |
| pixel size   | $330  \mu m$                    | 130 µm                       |                    |
| chip size  | $8 \times 10  mm^2$             | $10 \times 15  mm^2$         | → reduce tiling    |
| counting rate  | $2.10^{6} ph/s$                 | $2.10^{5}ph/s$               | ≡ count/surface    |
| energy range   | (5) $15 \rightarrow 25 keV$     | $7 \rightarrow 25 keV$       | new analog chain   |
| pixels/chip  | $24 \times 25 = 600$            | 80 × 120 ≈ 1.10 <sup>4</sup> |                    |
| pixels/module  | $8 \times 600 \approx 5.10^{3}$ | ≈ 1.10 <sup>5</sup>          |                    |
| pixels/detector  | $\approx 4.10^{4}$              | ≈ 5.10 <sup>5</sup>          |                    |
| geometries   | 8 v 8 or 2 v 5                  | 7 v 8 and 2                  |                    |

- Chip design has been carried out
- Prototype is expected for mid 2006.